



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Conf: 6433

Applicant: Mitsunori Mike et al.

Application No.: 10/681,156 Art Unit: 2635

Filed: October 9, 2003 Examiner: Jayesh A. Patel

For: METHOD AND APPARATUS OF

MEASURING ROTATIONAL AND

FLIGHT CHARACTERISTICS OF SPHERE

## **AMENDMENT UNDER 37 C.F.R.1.111**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 11, 2006, the period for response being extended by one month to April 11, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

This Paper includes Claim Set As Amended, Remarks and two Terminal Disclaimers.